

Mach-Zehnder Interferometer with Small Obstruction

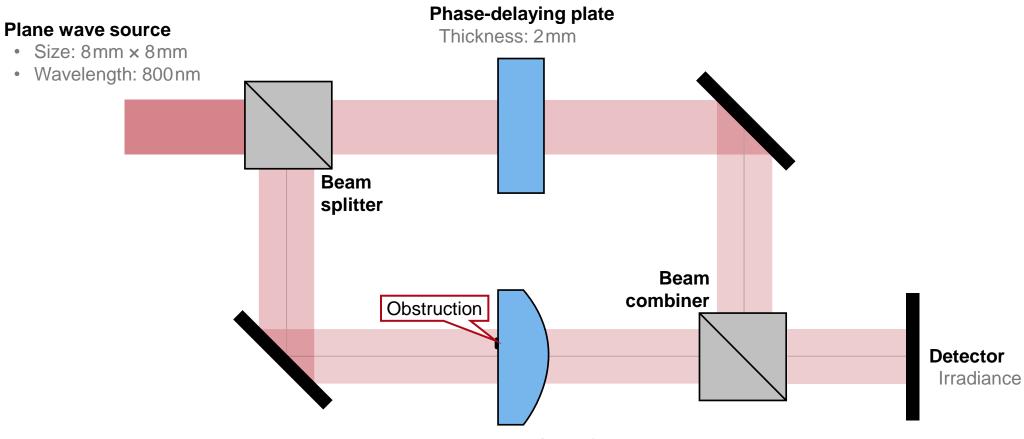
Abstract



The accurate simulation of light fields that encounter small light-blocking objects during propagation, leading to additional diffraction effects that must be finely sampled, represents a classic multi-scale simulation challenge that is numerically demanding. VirtualLab Fusion enables highly computationally efficient simulations by decomposing light into separate modes. This use case demonstrates the impact of light being blocked at a small point in a Mach-Zehnder interferometer system, such as by an interfering particle on the sample surface.

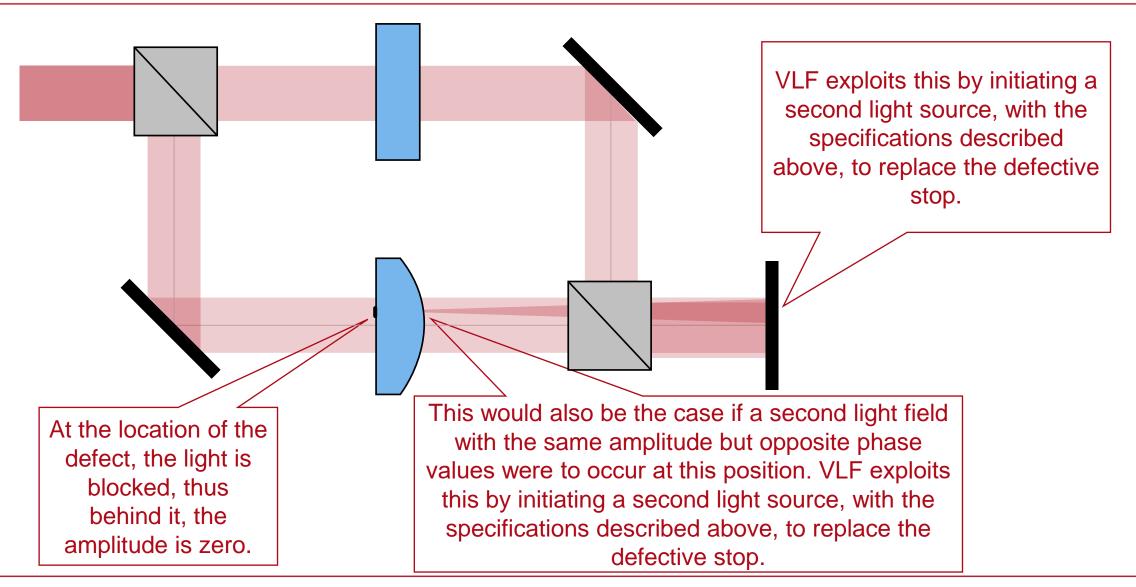
Application Scenario

Application Scenario: System Specifications

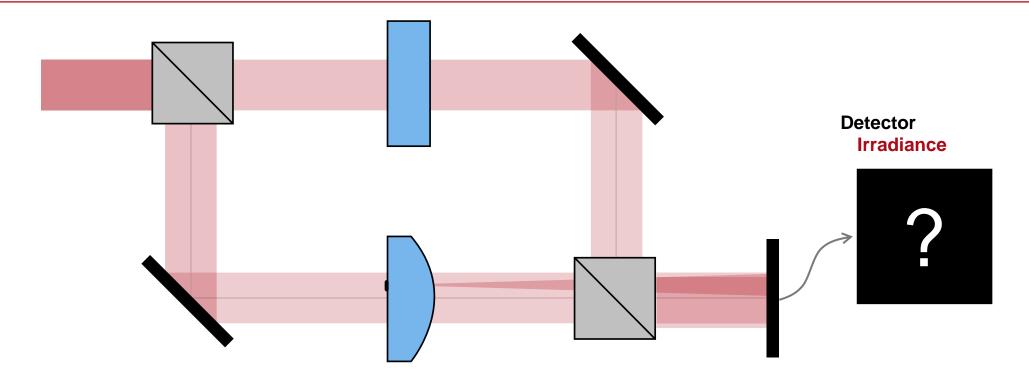


- Plano-convex lens with defect
- Radius of curvature (convex-part): 1 m
- Center thickness: 2mm
- Size of defect: 50 μm 300 μm

Application Scenario: Modeling & Simulation with Defect



Application Scenario: Task



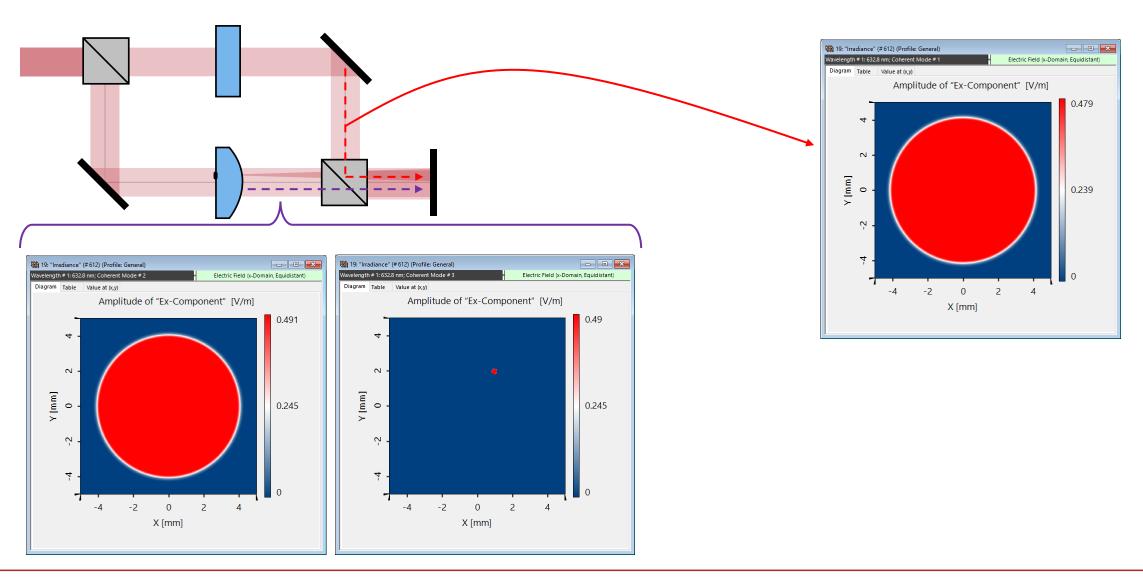
Task 1: Compare the irradiance results of the ideal system versus a system including a defect with a diameter of 300 μm.

Task 2: Reduce the defect's diameter size to 100μm and 50μm and calculate the irradiance patterns.

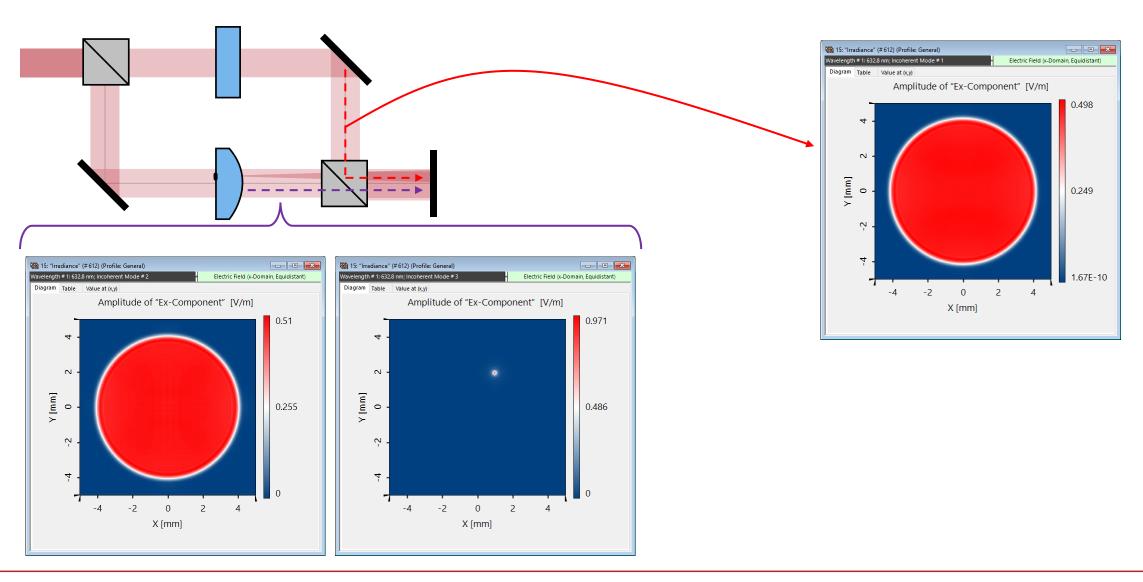
Results

Task 1: Simulation with and without Defect

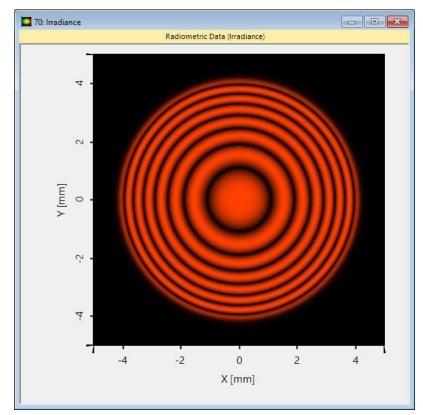
Separate Field Modes at Detector (without Diffraction)

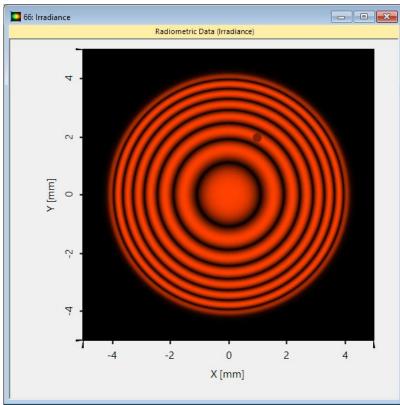


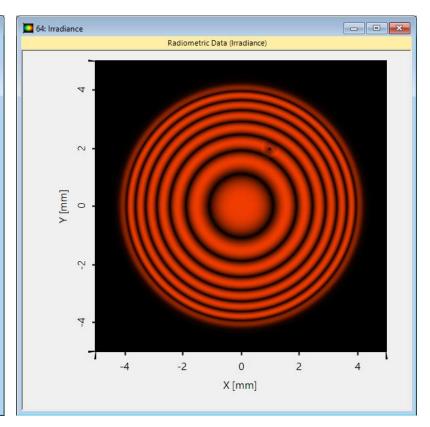
Separate Field Modes at Detector (with Diffraction)



Comparison





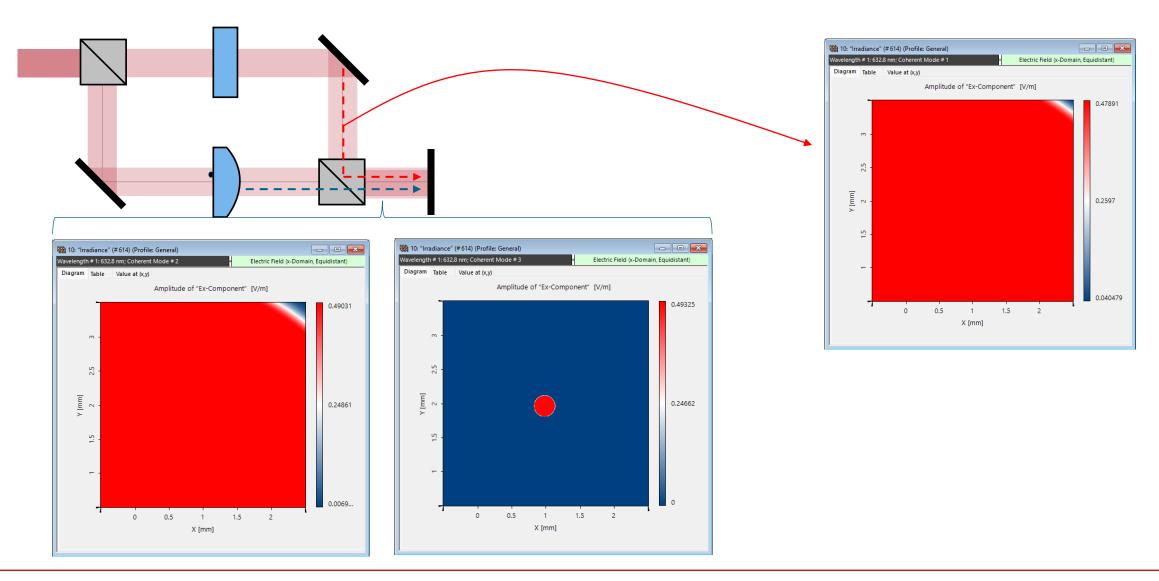


Irradiance of the unobstructed field

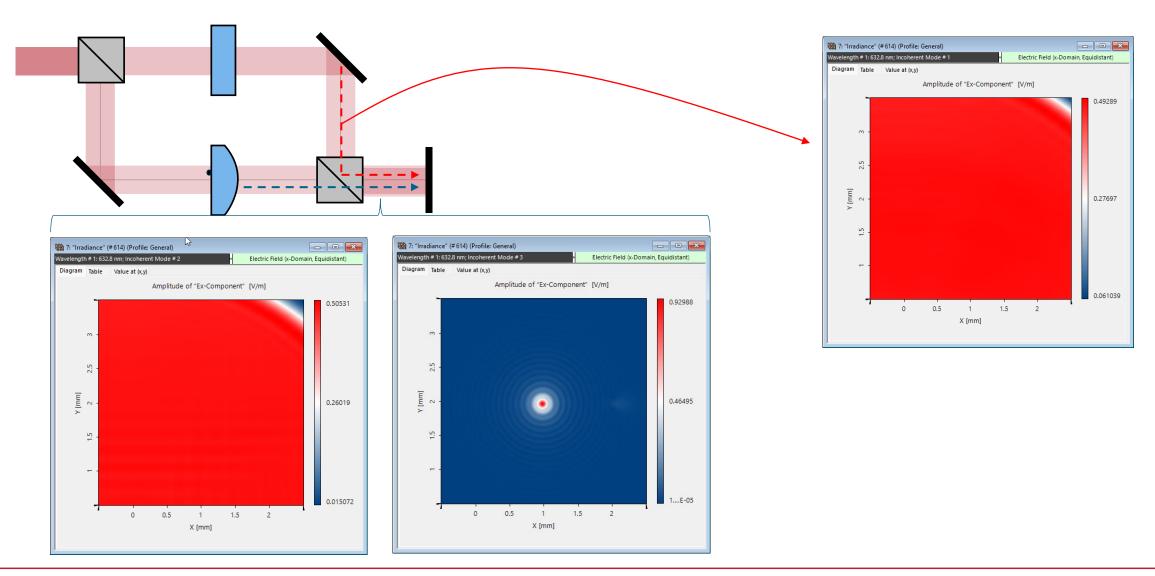
Irradiance of obstructed field without diffraction effects

Irradiance of obstructed field with diffraction effects

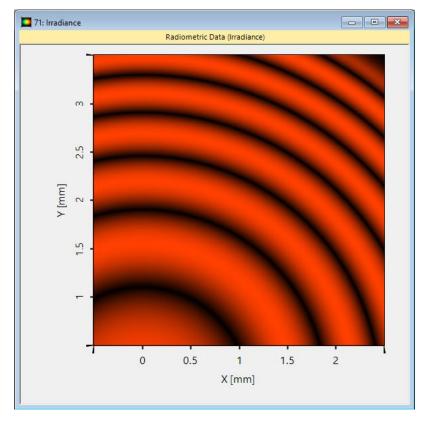
Field per Mode at Detector (without Diffraction) - Zoom

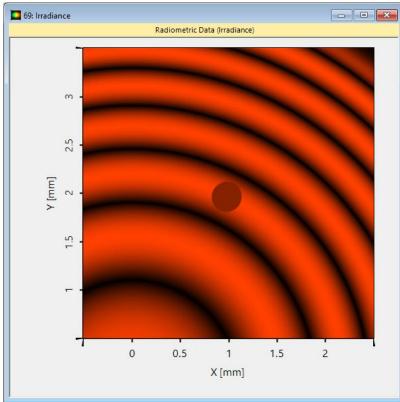


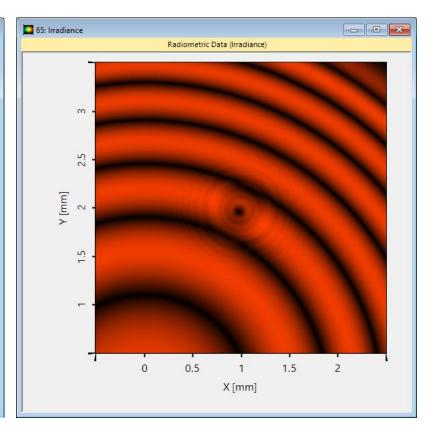
Field per Mode at Detector (with Diffraction)- Zoom



Comparison - Zoom







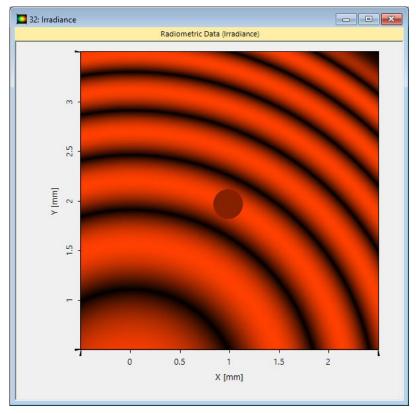
Irradiance of the unobstructed field

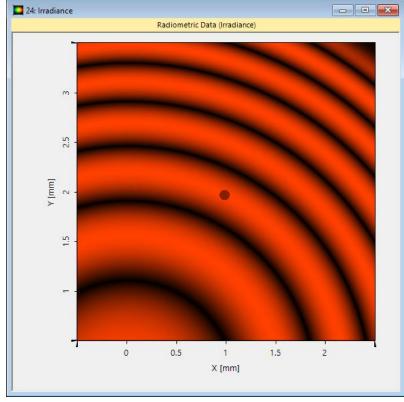
Irradiance of obstructed field without diffraction effects

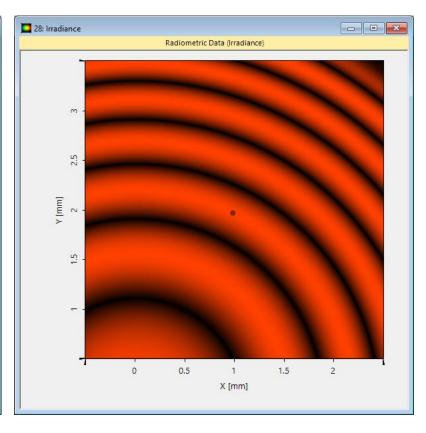
Irradiance of obstructed field with diffraction effects

Task 2: Different Stop Sizes

Variation of Defect Size without Considering Diffraction



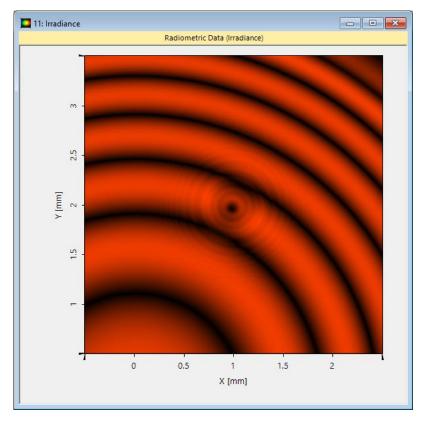


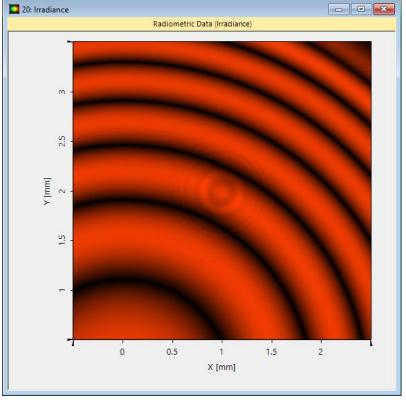


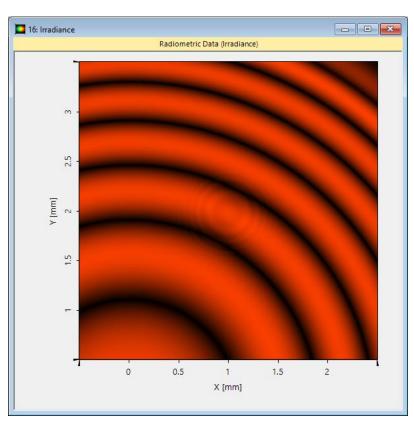
300 µm defect size 100 µm defect size 50 µm defect size

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Variation of Defect Size with Considering Diffraction







300 µm defect size 100 µm defect size

50 µm defect size

Workflows

LP Mode Source

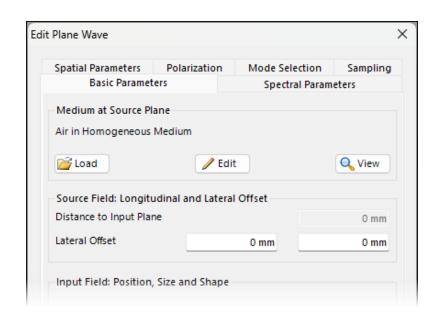
Source selection

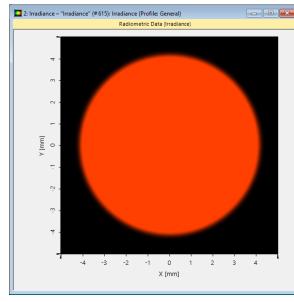
System setup

Detector selection

Getting it done in VirtualLab Fusion:

Plane Wave





System Setup

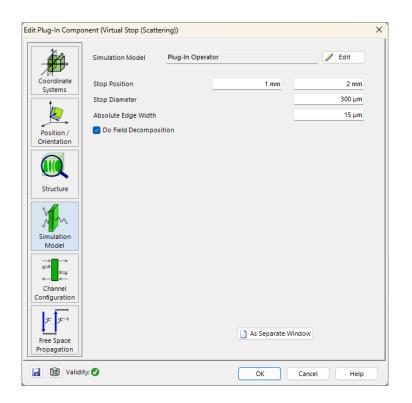
Source selection

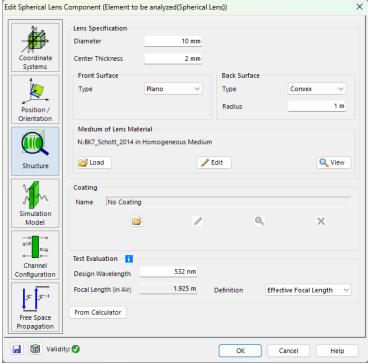
System setup

Detector selection

Getting it done in VirtualLab Fusion:

- Model lens by Spherical Lens component
- Include defect by Virtual Stop component





Detector Selection

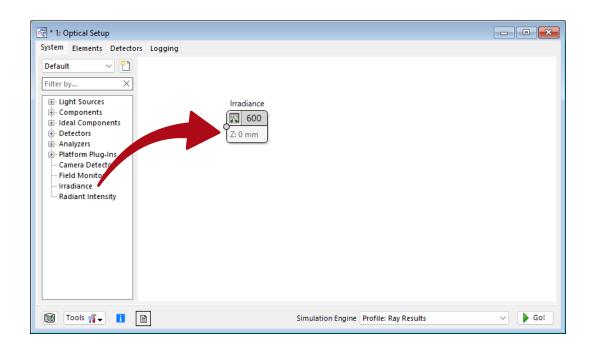
Source selection

System setup

Detector selection

Getting it done in VirtualLab Fusion:

Add Irradiance detector to your system.



Document Information

Title	Mach-Zehnder Interferometer with Small Obstructions
Document code	USC.0464
Publication date	05.09.2025
Required packages	
Software version	2025.2 (Build 1.118)*
Category	Use Case
Further reading	 Laser-Based Michelson Interferometer and Interference Fringe Exploration Fizeau Interferometer for Optical Testing

^{*} The files attached to this document require the specific version or later.